EXPRESS MAIL CERTIFICATE

DATE

LABEL NO.

L

L. Nelson #2/ Pre Amdt.A 12-26-01

2598/1G196US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Sang Kyeong YUN and Dong Hoon KIM

Filed: CONCURRENTLY .

NAME (PRINT)

For: PIEZOELECTRIC/ELECTROSTRICTIVE FILM ELEMENT-FORMED AT LOW

TEMPERATURE USING ELECTROPHORETIC DEPOSITION

PRELIMINARY AMENDMENT

Hon. Commissioner of Patents and Trademarks Washington, DC 20231

Sir:

Prior to examining the above-identified patent application, please enter the following amendment(s):

In the Claims:

Please amend Claims 22 and 41 to read as follows:

21, wherein the method further comprises a step of drying said piezoelectric/electrostrictive film between g) and h).

(Amended) The piezoelectric/electrostrictive film element in Claim

A